



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 3879

SERIAL NUMBER 10/694,030	FILING OR 371(c) DATE 10/28/2003 RULE	CLASS 257	GROUP ART UNIT 2815	ATTORNEY DOCKET NO. 1514.1033	
APPLICANTS Ji Yong Park, Suwon-city, KOREA, REPUBLIC OF; Hye Hyang Park, Suwon-city, KOREA, REPUBLIC OF;					
** CONTINUING DATA ***** <i>None</i> <i>me</i>					
** FOREIGN APPLICATIONS ***** <i>Yes</i> <i>me</i> REPUBLIC OF KOREA 2003-13829 03/05/2003					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 01/24/2004					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Allowance Acknowledged <i>[Signature]</i> Examiner's Signature Initials		STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 9	TOTAL CLAIMS 23	INDEPENDENT CLAIMS 5
ADDRESS 49455					
TITLE Polycrystalline silicon thin film, fabrication method thereof, and thin film transistor without directional dependency on active channels fabricated using the same					
FILING FEE RECEIVED 1496	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		